

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant(s): HAMASAKI   | Atty. Dkt.: 01-615 |
| Serial No.: Unknown  | Group Art Unit:    |
| Filed: Concurrently herewith   | Examiner:          |
| Title: METHOD OF RESIN-SEALING A SEMICONDUCTOR DEVICE, RESIN-SEALED SEMICONDUCTOR DEVICE, AND FORMING DIE FOR RESIN-SEALING THE SEMICONDUCTOR DEVICE |                    |

Commissioner for Patents  
Arlington, VA 22202

Date: April 1, 2004

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,



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| FORM PTO-1449 | ATTY. DKT NO. | 01-615          | SER. NO. |
|               | APPLICANT     | <b>HAMASAKI</b> |          |
|               | FILING DATE   | April 1, 2004   | GROUP    |

**REFERENCE DESIGNATION**

**U.S. PATENT DOCUMENTS**

| EXAMINER INITIAL |  | DOCUMENT NUMBER | DATE         | NAME | CLASS | SUB CLASS |
|------------------|--|-----------------|--------------|------|-------|-----------|
|                  |  | 5,077,237       | July 8, 1997 | Hara |       |           |
|                  |  |                 |              |      |       |           |
|                  |  |                 |              |      |       |           |
|                  |  |                 |              |      |       |           |

**FOREIGN PATENT DOCUMENTS**

**TRANSLATION**

|  |  | DOCUMENT NUMBER | DATE     | COUNTRY | NAME | CLASS | SUB CLASS | YES | NO               |   |
|--|--|-----------------|----------|---------|------|-------|-----------|-----|------------------|---|
|  |  |                 |          |         |      |       |           |     | Eng.<br>Abstract |   |
|  |  | JP-A-2-297946   | 12/10/90 | JAPAN   |      |       |           |     |                  | X |
|  |  | JP-A-2000-58573 | 2/25/00  | JAPAN   |      |       |           |     |                  | X |
|  |  | JP-A-7-130782   | 5/19/95  | JAPAN   |      |       |           |     |                  | X |
|  |  |                 |          |         |      |       |           |     |                  |   |
|  |  |                 |          |         |      |       |           |     |                  |   |
|  |  |                 |          |         |      |       |           |     |                  |   |

\* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

**OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)**

|          |                 |  |
|----------|-----------------|--|
|          |                 |  |
| EXAMINER | DATE CONSIDERED |  |